



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Jung-hyun LEE, *et al.*

Art Unit: 2812

Serial No. 10/617,767

Examiner: Not Assigned

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For: Deposition Method of a Dielectric Layer

Attorney Docket No.: 249/349

PRELIMINARY AMENDMENT UNDER 37 C.F.R. §1.115

Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

Prior to examination of the above-captioned U.S. patent application, kindly enter the following amendment and revised drawing figure, FIG. 2.